IQ+FLOW IQP-700C EPC (P1-control)

Microfluidic Back Pressure Controller



Microfluidic Back Pressure Controllers

Bronkhorst model IQP-700C Back Pressure Controllers are miniature devices which are ideal for use in cramped environments or in systems requiring minimum internal volume e.g. desktop equipment. The Pressure Controller has a chip-based (MEMS) sensor and is suited for pressure ranges between 0,1...0,5 bar and 2...10 bar absolute or gauge. Communication with the devices can be either in analog mode or digital over RS232 or RS485.

The ultra compact IQ+FLOW instruments are typically recommended for integration in analytical, bioprocessing and medical equipment.

Technical specifications

Measurement / control system

Absolute pressure sensors	Code: 1K5AC (chip sensor) - Ranges (FS): 0,5 1,5 bara - P-max: 3,0 bara
	Code: 3KOAC (chip sensor) - Ranges (FS): 1,0 3,0 bara - P-max: 6,0 bara
	Code: 10KAC (chip sensor) - Ranges (FS): 3,0 10 bara - P-max: 10 bara
	Code: 2K0AS (media-isolated) - Ranges (FS): 0,5 2,0 bara - P-max: 3 bara
	Code: 6K0AS (media-isolated) - Ranges (FS): 2,0 6,0 bara - P-max: 10 bara
	Code: 10KAS (media-isolated) - Ranges (FS): 3,0 10 bara - P-max: 10 bara
Relative pressure sensors	Code: 1K5GC (chip sensor) - Ranges (FS): 0,5 1,5 barg - P-max: 3,0 barg
	Code: 3K0GC (chip sensor) - Ranges (FS): 1,0 3,0 barg - P-max: 6,0 barg
	Code: 10KGC (chip sensor) - Ranges (FS): 3,0 10 barg - P-max: 10 barg
	Code: 0K6GS (media-isolated) - Ranges (FS): 0,2 0,6 barg - P-max: 1 barg
	Code: 2K0GS (media-isolated) - Ranges (FS): 0,5 2,0 barg - P-max: 3 barg
	Code: 6K0GS (media-isolated) - Ranges (FS): 2,0 6,0 barg - P-max: 10 barg
	Code: 10KGS (media-isolated) - Ranges (FS): 3,0 10 barg - P-max: 10 barg
Accuracy (incl. linearity and	\leq ± 0,5 % FS
hysteresis)	(Based on calibration at ambient temperature)
Repeatability	\leq ± 0,2 % FS
Pressure rangeability	measurement: 1 : 50 (2100%)
	control: 1:5 (with flow range 1:50)
Fluids	Chip-sensor: dry, clean, non-flammable and non-corrosive gases. Absolute pressure sensors not suitable
	for Helium.
	Media-isolated sensor: Gases compatible with aluminium or stainless steel SS316L and Viton.
Operating temperature	5 50 °C
Temperature sensitivity	span: 0,1% RD/°C; zero: 0,05% FS/°C
Max. Kv-value	2.37×10^{-3}
Leak integrity, outboard	1×10^{-6} mbar·l/s He

Mechanical parts

Material (wetted parts)	body: aluminium (default) or stainless steel SS316L (option); chip sensor (default): Si, SiOx, epoxy, aluminium; media-isolated sensor (option): stainless steel SS316L
Process connections	optional: 10-32 UNF threaded internal nut with 1/16" ferrule (SS316 or Peek), 1/16" or 1/8" OD compression type
Seals	FKM/Viton® seals and plunger (default); FKM/Viton® seals and FFKM/Kalrez® plunger (option)
Weight	120 g (Aluminium) / 180 g (SS316L)
Ingress protection	IP40

Electrical properties

Readout sample time	2 msec
Power supply	+15 24 Vdc
Max. power consumption	100 mA
Analog output	05 (10) Vdc or 0 (4)20 mA (sourcing output)
Digital communication	RS232, RS485 (Modbus-RTU/ASCII or FLOW-BUS)

Electrical connection

Control valve options

External actuator options to be connected to the controller

Ex-proof specifications

Approvals / certificates

Technical specifications subject to change without notice.

For dimensional drawings and hook-up diagrams please visit the <u>product page</u> on our <u>website</u>

Recommended accessories





E-8000 SERIES

Digital Readout / Control Systems

push buttons

Bright, wide angle, 1.8" display (TFT technology) User friendly operation, menu driven with 4

PIPS SERIES

Plug-in Power Supply

For lab-style or industrial devices Interchangeable plugs (Euro, UK, USA, Australian, IEC) for mains connection

Related products



IQ+FLOW IQPD-700C EPC (P1-CONTROL)

Min. pressure 0,1...0,5 bar Max. pressure 2...10 bar Ultra compact; downported MEMS technology



IQ+FLOW IQP-600C EPC (P2-CONTROL)

Min. pressure 0,025...0,5 bar Max. pressure 0,5...10 bar Ultra compact MEMS technology



IQ+FLOW IQP-500C

Min. pressure 0,01...0,5 bar Max. pressure 0,2...10 bar Ultra compact MEMS technology



IQ+FLOW IQF-200C MFC

Min. flow 0...10 mln/min Max. flow 0...5 ln/min Pressure rating 10 bar Ultra compact MEMS technology



Bronkhorst High-Tech designs and manufactures innovative instruments and subsystems for low-flow measurement and control for use in laboratories, machinery and industry. Driven by a strong sense of sustainability and with many years of experience, we offer an extensive range of (mass) flow meters and controllers for gases and liquids, based on thermal, Coriolis and ultrasonic measuring principles. Our global sales and service network provides local support in more than 40 countries. Discover Bronkhorst®!